Effects of argon micro-bubble assistance on the performance of 3D integrated micro solution plasma

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We have previouslyproposed a novel three-dimensionally integrated micro solution plasma (3D IMSP)reactor, which can generate large number of microplasmas in a porous dielectricmaterial filled with a gas/liquid mixed medium. However, 3D IMSP is noteffective for the treatment of an aqueous solution with a high electricalconductivity, which was one of disadvantages of 3D IMSP. In this work, we haveintroduced micro argon bubbles into the 3D IMSP reactor to treat water withhigher electrical conductivity. We employed argon micro-bubbles for overcomingthe weak point of the 3D IMSP reactor. The aqueous solutions used for this preactor that electrical conductivities of 1-1000 uS/cm, which were prepared by mixing KCl with deionized water and methylene blue. We confirmed that themicro-bubble assisted 3D IMSP reactor can generate plasma in the aqueoussolution with electrical conductivity up to 500 uS/cm, while conventional 3DIMSP cannot. Furthermore, micro-bubble assistance has an effect of reducing theignition- and sustain-voltages of 3D IMSP.

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